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DATE MAILED: 10/04/2004

APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO.	
10/733,980	12/10/2003	Justin Jia-Jen Hwu	HSJ9-2003-0115US1	1278	
7590 10/04/2004			EXAMINER		
Robert O. Gui	illot, Esq.	YEVSIKOV, VICTOR V			
INTELLECTU	AL PROPERTY LAW	OFFICES			
Suite 660	•		ART UNIT	PAPER NUMBER	
1901 South Bascom			2825		
Campbell, CA	95008	DATE MAN DD. 10/04/0004			

Please find below and/or attached an Office communication concerning this application or proceeding.

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	Applic	ation No.	Applicant(s)			
		3,980	HWU ET AL.			
Office Action Summary	Exami	ner	Art Unit			
		V Yevsikov	2825			
The MAILING DATE of this community Period for Reply	inication appears on	the cover sheet with the c	correspondence add	ress		
A SHORTENED STATUTORY PERIOD THE MAILING DATE OF THIS COMMUI - Extensions of time may be available under the provision after SIX (6) MONTHS from the mailing date of this cor - If the period for reply specified above is less than thirty - If NO period for reply is specified above, the maximum - Failure to reply within the set or extended period for reply any reply received by the Office later than three months earned patent term adjustment. See 37 CFR 1.704(b).	NICATION. ns of 37 CFR 1.136(a). In nonmunication. (30) days, a reply within the statutory period will apply an ally will, by statute, cause the	event, however, may a reply be tirestatutory minimum of thirty (30) day d will expire SIX (6) MONTHS from application to become ABANDONE	nely filed s will be considered timely. the mailing date of this con () (35 U.S.C. § 133).	nmunication.		
Status						
1) Responsive to communication(s) fi	led on <u>10 Decembe</u>	r <u>2003</u> .				
3) Since this application is in conditio	n for allowance exce	ept for formal matters, pro	secution as to the i	merits is		
closed in accordance with the prac	closed in accordance with the practice under Ex parte Quayle, 1935 C.D. 11, 453 O.G. 213.					
Disposition of Claims			•			
4) ⊠ Claim(s) 1-22 is/are pending in the 4a) Of the above claim(s) is/5) □ Claim(s) is/are allowed. 5) □ Claim(s) 1-22 is/are rejected. 7) □ Claim(s) is/are objected to. 8) □ Claim(s) are subject to restrict the state of the subject to restrict the subject the subject the subject the subject the subject the subject	are withdrawn from					
Application Papers						
9)⊠ The specification is objected to by to 10)⊠ The drawing(s) filed on 10 Decembor Applicant may not request that any objected Replacement drawing sheet(s) including 11)□ The oath or declaration is objected	er 2003 is/are: a) \boxtimes ection to the drawing(some the correction is required.	s) be held in abeyance. Security uired if the drawing(s) is ob-	e 37 CFR 1.85(a). jected to. See 37 CFF	R 1.121(d).		
Priority under 35 U.S.C. § 119						
 12) Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a) All b) Some * c) None of: 1. Certified copies of the priority documents have been received. 2. Certified copies of the priority documents have been received in Application No 3. Copies of the certified copies of the priority documents have been received in this National Stage application from the International Bureau (PCT Rule 17.2(a)). * See the attached detailed Office action for a list of the certified copies not received. 						
Attachment(s)						
1)	PTO-948\	4) Interview Summary Paper No(s)/Mail Da				
2) ☐ Notice of Dialisperson's Patent Diawing Review (3) ☐ Information Disclosure Statement(s) (PTO-1449 o Paper No(s)/Mail Date <u>121003</u> .		5) Notice of Informal P		152)		

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DETAILED ACTION

Claim Rejections - 35 USC § 112

Claims 1-22 are rejected under 35 U.S.C. 112, first paragraph, as failing to comply with the enablement requirement. The claim(s) contains subject matter which was not described in the specification in such a way as to enable one skilled in the art to which it pertains, or with which it is most nearly connected, to make and/or use the invention. The applicant recites a wafer having a plurality of test features placed thereon which project from the wafer surface. These test features are stated to be composed of a hard upper surface layer. The specification indicates that these test features are polished in a procedure wherein the process proceeds in a manner as depicted in Figure 1. This figure shows a timed sequence of the polishing process. It is not seen how if the test features 24 are composed of the same hard material how the test feature on 36 and 40 are removed prior to the features on elements 20 on the right of the drawing under T=2. If the material 24 is the same material for all elements 20, then the layers should be removed wherein each has a portion of element 24 thereon until the last bit is removed from all element 20s. Consequently, while the applicant claim is understandable the manner of polishing and the "polished" recitation on line 5 of claim 1 is not enabled by the specification. In other words, the examiner does not see how one would come up with the claimed device and achieve its aim in the polishing realm as highlighted in Figure 1.

Claims 12-22 are rejected under 35 U.S.C. 112, first paragraph, as based on a disclosure which is not enabling. Steps in the formation of the magnetic head which are

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critical or essential to the practice of the invention, but not included in the claim(s) is not enabled by the disclosure. See *In re Mayhew*, 527 F.2d 1229, 188 USPQ 356 (CCPA 1976).

The subject matter of the claims is drawn to a method or process of fabricating a magnetic head upon a wafer surface. However, the only steps recited are to the CMP processes. No steps are provided coupling this process with the formation of the magnetic head. The specification only couples the use of this CMP step with the magnetic head in only a general and unknown manner.

.Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to Victor Yevsikov whose telephone number is 571-272-1910. The examiner can normally be reached on Monday-Fridays 8:00-5:30.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Matthew S. Smith can be reached on 571-272-1907. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

MATTHEW SMITH
SUPERVISORY PATENT EXAMINER
TECHNOLOGY CENTER 2800

V.4.